

<b>Notice of References Cited</b>	Application/Control No. 10/644,494	Applicant(s)/Patent Under Reexamination VAYANOS ET AL.	
	Examiner Edan Orgad	Art Unit 2684	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	C	US-2003/0067899	04-2003	Chen et al.	370/335
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**NON-PATENT DOCUMENTS**

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